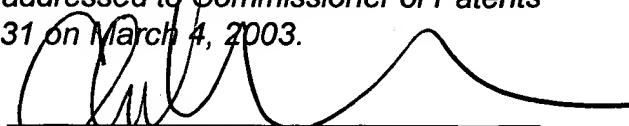




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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Christa M. Caliva

Applicant : Jerome Tsu-Rong Chu, et al.

Application No. : 09/964,227

Filed : September 26, 2001

Title : METHOD AND STRUCTURE FOR
MODULAR, HIGHLY LINEAR MOS
CAPACITORS USING NITROGEN
IMPLANTATION

Grp./Div. : 2822

Examiner : J. Vockrodt

Docket No. : 42022/MJM/A717

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RESPONSE TO OFFICE ACTION DATED NOVEMBER 4, 2002

Assistant Commissioner for Patents
Washington, D.C. 20231

Post Office Box 7068
Pasadena, CA 91109-7068
March 4, 2003

Commissioner:

In response to the Office action of November 4, 2002, please amend the above-identified application as follows, and re-examine and reconsider the application in view of the amendments and remarks provided.

A Petition for a one-month extension of time and the appropriate fee, are enclosed herewith.